



# Industry-academia matching event on Micro-Pattern Gaseous Detectors

## jeudi 26 avril 2012

**Manufacturing** - Amphitheatre M. Vivargent (16:20 - 16:35)

time	[id] title	presenter
16:20	[24] Needs for the micromegas for the ATLAS muon system upgrade	WOTSCHACK, Joerg

## **vendredi 27 avril 2012**

### **Manufacturing - Amphitheatre M. Vivargent (09:50 - 11:30)**

time	[id] title	presenter
09:50	[9] MPGD manufacturing	DE OLIVEIRA, Rui
10:35	[10] MICROMEGAS industrialisation effort at ELVIA	BILLANT, Michel
10:55	[14] ELTOS company profile	LEQUERRÉ, Pascal
11:15	[23] Efforts for industrialization of GEMs and Micromegas supported by the CERN	FORMENTI, Fabio